

Notice of References Cited	Application/Control No. 10/069,058	Applicant(s)/Patent Under Reexamination BARGE ET AL.	
	Examiner Marcos D. Pizarro-Crespo	Art Unit 2814	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Sorab K. Ghandhi, VLSI Fabrication Principles: Silicon and Gallium Arsenide, 2 nd ed., 1994, John Wiley & Sons, Inc., New York, pp.726
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